

<b>PTO-1449</b>  <b>Information Disclosure Citation in an Application</b>		<b>Application No.</b>  <b>Docket Number</b> <b>TI-37411</b> <b>(032350.B583)</b>		<b>Applicant(s)</b> <b>Roger M. Ikeda</b>  <b>Group Art Unit</b>  <b>Filing Date</b> <b>December 30, 2003</b>			
<b>U.S. PATENT DOCUMENTS</b>							
		DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
MR	A	5,442,414	08/15/1995	Janssen et al.	353	98	05/10/1994
MR	B	2002/0126264 A1	09/01/2002	Dewald et al.	353	97	03/05/2002
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						
	L						
	M						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	<div style="text-align: center;">TRANSLATION</div> <div style="display: flex; justify-content: space-between;"> <span>YES</span> <span>NO</span> </div>
	N						
	O						
	P						
<b>NON-PATENT DOCUMENTS</b>							
		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					DATE
MR	Q	L.J. Hornbeck, "Digital Light Processing™: A New MEMS-Based Display Technology," Texas Instruments, white paper, 22 pages					
MR	R	G. Hewlett and W. Werner, "Analysis of Electronic Cinema Projection with the Texas Instruments Digital Micromirror Device™ Display System," Texas Instruments, white paper, 10 pages					
MR	S	S.M. Penn, et al., "Adaptive Illumination Modulator," S/N 10/326,237, currently pending					12/20/2003
	T						
	U						
	V						
<b>EXAMINER</b> /Manucher Rahmjoo/ (01/18/2007)				<b>DATE CONSIDERED</b> 01/18/2007			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							